

Approved for entry IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
7/31/09

HN

Response Under 37 C.F.R. § 1.116 Expedited Procedure

In re application of: Kenji Suzuki

Application No. 10/556,712

Filed: November 9, 2005

Confirmation No. 6606

For: ILLUMINATION OPTICAL SYSTEM,
PROJECTION/EXPOSURE DEVICE,
MICRO DEVICE MANUFACTURING
METHOD, ILLUMINATION DEVICE
MANUFACTURING METHOD,
PROJECTION/EXPOSURE DEVICE
ADJUSTMENT METHOD, AND
PROJECTION/EXPOSURE DEVICE
MANUFACTURING METHOD

Examiner: Hung Nguyen

Art Unit: 2851

Attorney Reference No. 4641-71773-01

**FILED VIA EFS
ON JULY 28, 2009**

COMMISSIONER FOR PATENTS
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**REPLY TO FINAL OFFICE ACTION, INCLUDING
APPLICANT'S INTERVIEW SUMMARIES**

This paper is submitted in reply to the final Office action dated June 1, 2009.

Remarks begin on page 2.